

# 6 Designing and building astronomical instruments

Developing new instrument: many important factor & constraint

## 6.1 Basic Requirements

First step: Understanding/Defining the applications (science goal)

**Vital to design instrument**

- Design (Slit spec, fiber spec, multi slit, ...)
- Constraint (FoV, angular resolutions, wavelength range, ...)

↑ **Depend on Science goal**

Too many science goals: **very complex instrument**

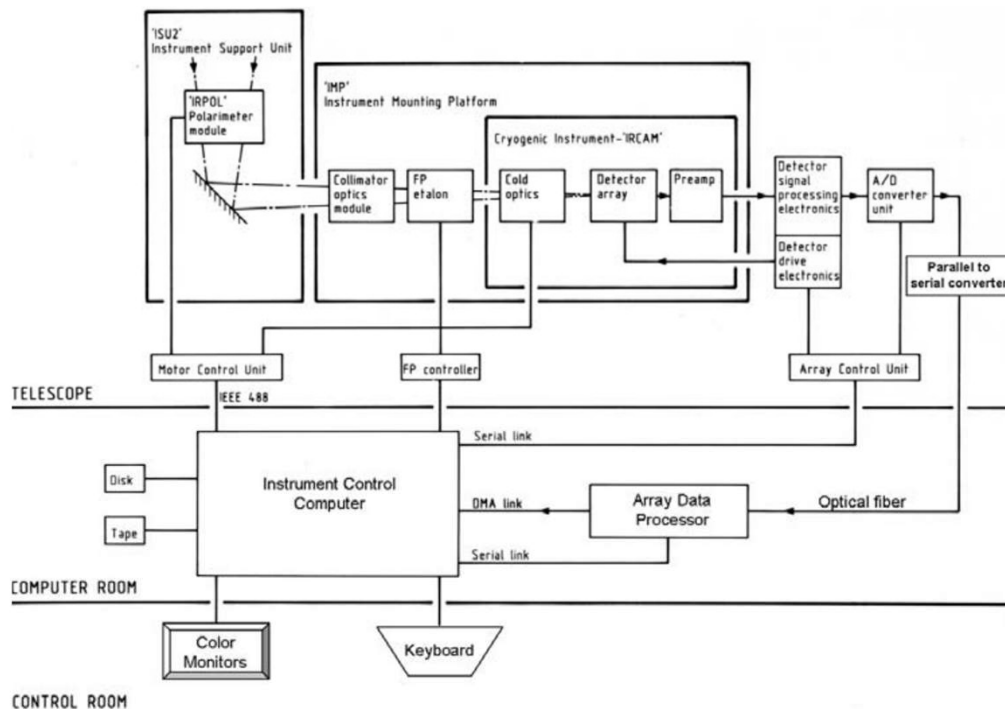
**Define science goal  $\Rightarrow$  choose approaches/designs**

## 6.2 Overall System Layout

Designing process ⇒

**Laying out essential components & interconnections**

Preferable approach: **Partition into modules**



Example of design of IR Camera  
**Basic features is similar to modern instrument**

**Figure 6.1.** A block diagram layout of an entire camera system for a large telescope. The illustration is for IRCAM, the first infrared camera system developed for the 3.8m U.K. Infrared Telescope.

## **Fundamental items for instruments:**

- 1. Detector**
- 2. Opto-mechanical system**
- 3. Enclosure and cooling system**
- 4. Signal-processing hardware/ADC**
- 5. Electronics for detector**
- 6. Timing logic and synchronization circuits**
- 7. “motion control/maintain” system**
- 8. Electronic interface to a computer**
- 9. Host computer**
- 10. Image display system & image processing software**

## 6.3 Optical Design

Young astronomers & Anyone interested in:  
**Important to train optical design**

### 6.3.1 First order to ray tracing

**Process of optical design:**

- 1. Basic design**
- 2. Constraints**
- 3. Performance specification**
- 4. Ray tracing & optimization**
- 5. Tolerance analysis**

# Basic design

## Design with considering of simple condition

(Simple lens, Plate Scale, FoV, F number, ...)

⇒ **Construct basic design**

- Simple lens (without considering of aberrations):  
Estimate required power, beam size, and detector size
- Simple displacement & deviations of plate  
Consider the displacement of filter, window of vacuum enclosures, polarizing beam-splitters

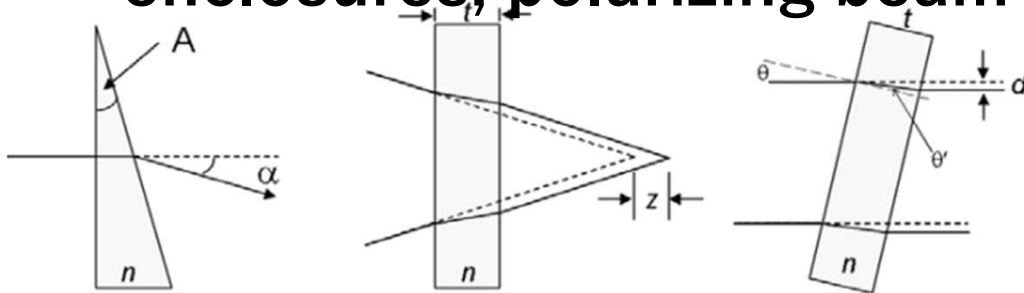


Figure 6.3. The effect of wedges and tilted plane-parallel plates on the optical beam.

$$\left. \begin{aligned}
 \alpha &\approx (n-1)A && \text{thin wedge} \\
 z &= \frac{(n-1)t}{n} && \text{parallel plate in converging beam} \\
 d &= t \sin \theta \left( 1 - \frac{\cos \theta}{n \cos \theta'} \right) && \text{displacement by parallel plate}
 \end{aligned} \right\} \quad (6.1)$$

# Identify & list all the known constraints

- Wavelength range
- Transmittance
- Desired back focal length
- Size
- Weight
- Ability to test and align optics
- Cost of fabrication
- ...

# Ray tracing

Performed to check & correct optical design

Program for ray tracing (like Code V released by ORA):

- Analyze the system entered to computer
- Optimize a given design or search for different designs within arbitrary constraints

Useful to study what the effect of variations in design, and  
What compensation techniques can be applied

## 6.3.2 Aberrations

**Aberrations: geometric factors reduce image quality**

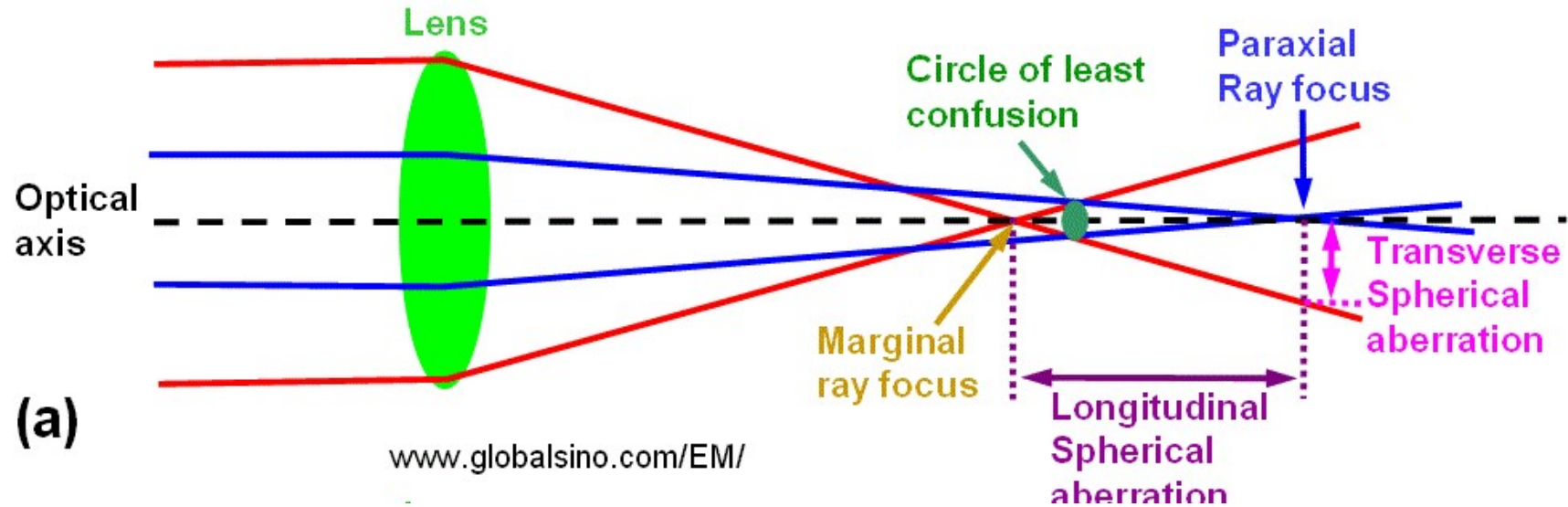
$$\sin \theta = \theta - \frac{\theta^3}{3!} + \frac{\theta^5}{5!} - \frac{\theta^7}{7!} + \frac{\theta^9}{9!} - \dots \quad (6.2)$$

- ①  **$\sin \theta \approx \theta$ : possible to obey the paraxial equation/theory (irrespective of value of  $\theta$  in Snell's Law)**
- ②  **$\sin \theta \approx \theta - \theta^3/6$ : we are led to a useful set of Seidel aberrations**

**Seidel aberrations: general term for aberrations in monochromatic light**  
**Aberrations of multi-color: Seidel + chromatic aberrations**



# Spherical aberration



## Diameter of blur circle

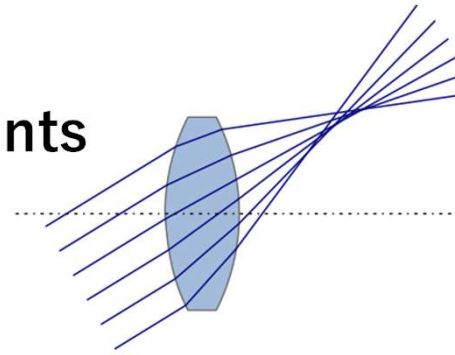
spherical mirror:	$\beta = 1/128F^3$	}	(6.3)
parabolic mirror:	$\beta = 0$		
simple lens:	$\beta = n(4n - 1)/128(n + 2)(n - 1)^2 F^3$		

## Coping method

- Small aperture (pupil)
- Neutralize with positive and negative element
- Eliminate with parabolic surface

# Coma aberration

Caused by parallel rays from off-axis points



Angular size of tangential coma:

spherical mirror:  $\beta = (3/16)(\theta/F^2)[1 - z/2f]$  (6.6)

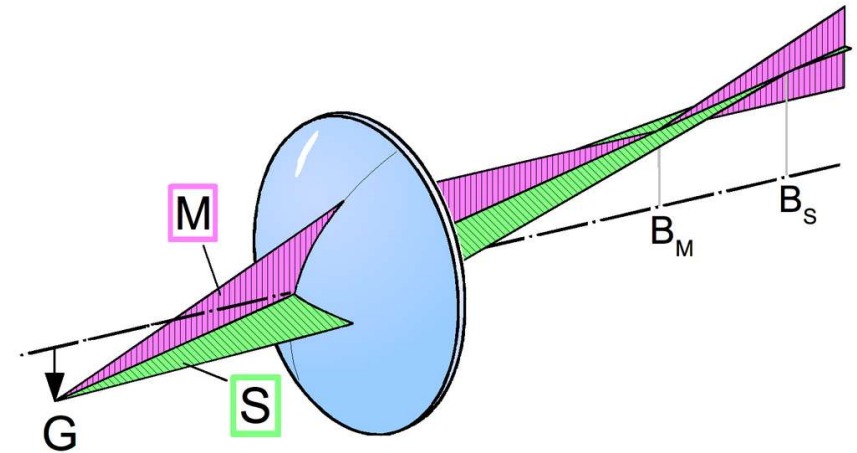
## Coping method

- Small aperture
- Diaphragm at the center of spherical mirror (Schmidt Telescope)
- Fulfill Abbe condition

$$\sin \theta / \sin \theta' = \theta_p / \theta'_p = \text{constant} \quad (6.7)$$

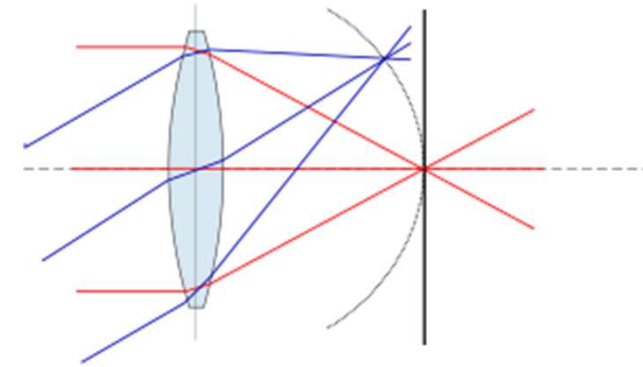
# Astigmatism

- Rays that propagate in two perpendicular planes have different focus
- Caused by tilted plates (dichroic beam-splitter, filter placed in a converging beam)
- Blurred image is seen between two focuses



# Field curvature

- Natural tendency for optical systems to image better on curved surfaces (Petzval surface) than on flat planes
- Positive element and negative one shows opposite curvature

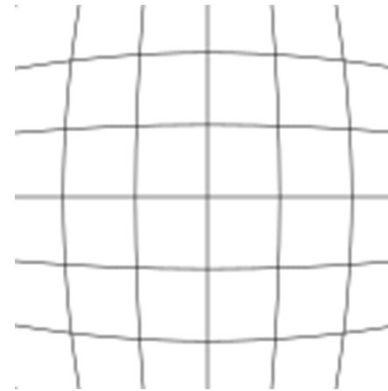


## Coping method

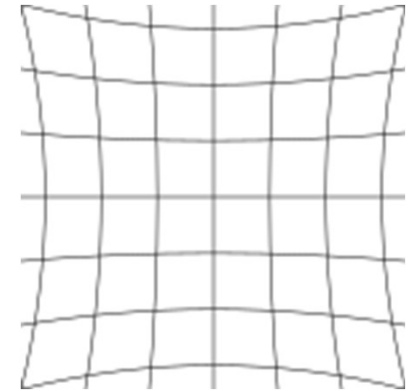
- Field flattening lens
- Correct with combination of two elements

# Distortion

- Image of an off-axis point does not form at the predicted position (paraxial theory)
- 3 types:
  1. Pincushion
  2. Barrel
  3. Keystone



Barrel



pincushion

Coping method:

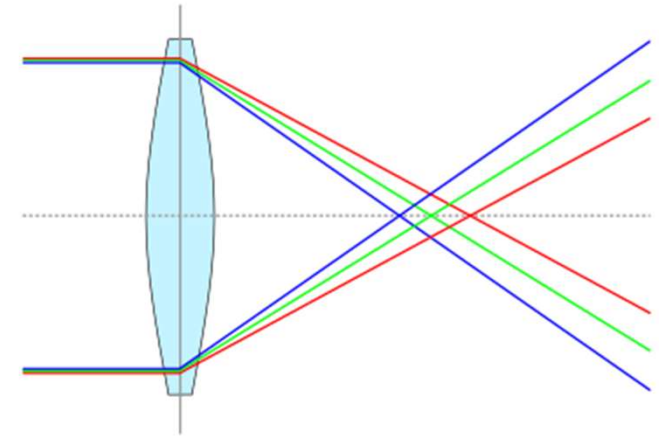
Remove with computer processing

# Chromatic aberration

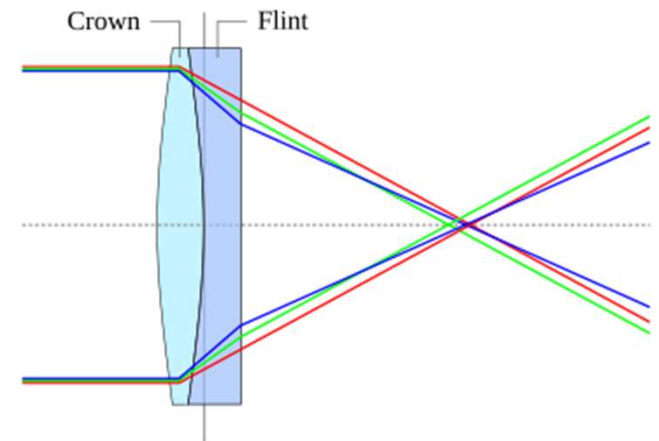
- Caused by the difference of refractive index depends on wavelength
- Longitudinal chromatic aberration: difference in focus
- Lateral chromatic aberration: difference in image height
- No chromatic aberration with mirror

Coping method:

Correct with combination of two lenses  
(different material)



Example of longitudinal chromatic aberration



### 6.3.3 Wavefront Error

Optical path difference (OPD): difference between the real wavefront and the best fitting spherical surface

**Wavefront Error: Deviation of the observed wavefront from perfect** (specified in terms of the peak-to valley OPD)

Wavefront Error: deteriorate PSF

⇒ **Decrease image quality and intensity at the center**

**Strehl ratio: fraction of light within any angular radius  $\theta$**

$$S = \exp[-(4\pi\sigma/\lambda)^2]$$

( $\sigma$ : rms amplitude of the surface roughness)

## Quantified performance of the optical design

- Performed with distortion map, limits of scattering, wavefront error budget, etc.
  - **Ray-tracing programs provide several important tools**
1. Spot diagrams(cluster of impact points on the focal plane)
  2. Encircled energy (total amount of energy within a circle)
  3. Tangential ray fans (variations of an aberration)
  4. Modulation transfer function (modulations of image to estimate required resolution)



# Control of aberrations/Making aspheric plates

Control of aberrations: making surface of the primary optical component to correct aberrations

$$z = \boxed{\frac{cr^2}{1 + \sqrt{1 - (1 + K)c^2r^2}}} + \alpha_1 r^2 + \alpha_2 r^4 + \alpha_3 r^6 + \dots \quad (6.8)$$

Conic curve surface      Aspheric surface

$$\sum_{i=0}^N A_i Z_i(\rho, \varphi)$$

(6.9)

✖ For deformable mirror  
and multiple mirrors

Aspheric plates: carved out with computer-controlled diamond-tipped cutters

Material of mirror support & attachments: same with mirror  
⇒ No requirement to consider differential thermal contraction

**OAP(Off-Axis Parabola):** section of a paraboloid that does not contain the vertex

- **Correct coma aberration (Mersenne relay, use opposing off-axis parabolas)**
- **TMR(three-mirror relay):** Use two OAP mirrors (big primary mirror and small secondary mirror) to lead light back to the other sections of primary mirror
- **TMA (three mirror anastigmat):** all three mirrors are conic (strong keystone distortion)

**Spherical aberrations and achromatic doublets**

**Split the power and double the number of components (like Cooke triplet)**

## 6.3.4 Coatings and interference filters

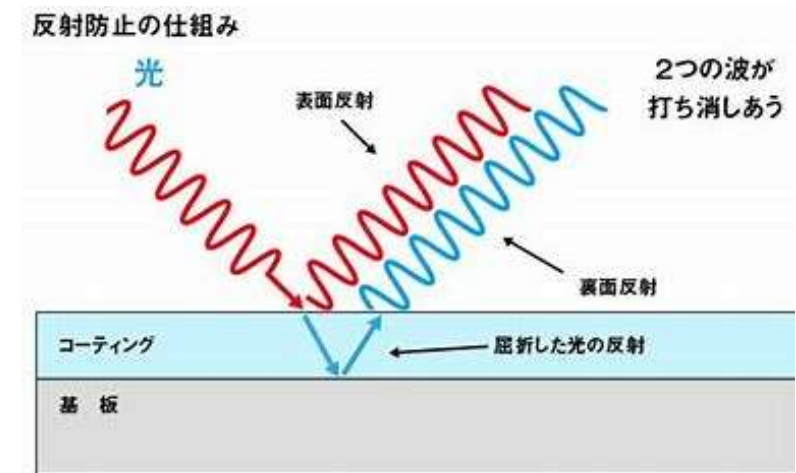
Anti-reflection coating: prevent reflection on optical components with coating on components

- Reflectance of a surface:

$$R = \left( \frac{n - 1}{n + 1} \right)^2 \quad (6.10)$$

- Basic relationship of interference:

$$2nd = \left(m + \frac{1}{2}\right)\lambda \quad (6.11)$$



⇒ Minimum thickness for coating:  $d = \lambda / 4n$  (quarter-wave layer)  
Ideal value of  $n$ :  $\sqrt{n_g}$  ( $n_g$ : refractive index of components)

## Multi-layer coatings

- Using several materials to provide a reduction in reflectance in broad band wavelength
- Coatings on CCD: make quantum efficiency better (Silicon:  $n=4 \Rightarrow 36\%$  reflection loss)

## Narrow-band filter and Fabry Perot etalon

- Interference equation:  $m \lambda = 2 n d \cos \theta$
- Adjusting inclination ( $\theta$ )  $\Rightarrow$  change wavelength range